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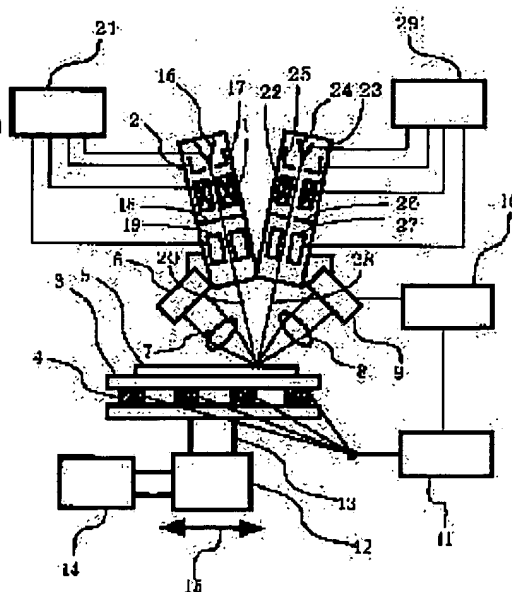
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(54) METHOD AND DEVICE OF MANUFACTURING OPTICAL MASTER DISK

(57)Abstract:

PROBLEM TO BE SOLVED: To accurately emit an electron beam to a prescribed position on a master disk, in manufacturing an optical master disk using an electron beam.

SOLUTION: In cutting the master disk, plural tracks are designed to be formed during one revolution of the master disk. In addition, a control mechanism is provided so that a distance is constant between the master disk and the objective lens of an electron gun.



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